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(Fu)

PATENT  
790001-2043



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Makoto FUJIWARA et al.  
Serial No. : 10/775,017  
Filing Date : February 9, 2004  
For : **SEMICONDUCTOR DEVICE AND MANUFACTURING  
METHOD THEREOF**  
Examiner : Ida M. Soward  
Art Unit : 2822

745 Fifth Avenue  
New York, NY 10151

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Date of Deposit: January 19, 2006

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Charles Jackson

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**AMENDMENT AFTER ALLOWANCE UNDER 37 C.F.R. § 1.312  
AND BEFORE PAYMENT OF THE ISSUE FEE**

**Mail Stop Issue fee**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This Amendment is responsive to the Notice of Allowance mailed on  
December 20, 2005 and to the Examiner's Amendment cited in the Notice of Allowance.